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# Synthesis of Carbon Dots using Citric acid (Solvent Free reaction)

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Protocol status: Working We use this protocol and it's working

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## Abstract

Carbon Dots are the fluorescent nanoparticles that have wide range of applications. Facile synthesis of Carbon Dots paves the way for making this material mainstream for use. Synthesis of Carbon Dots by using Citric acid as the precursor in a solvent free reaction is a easy method in which the synthesized Carbon Dots shows fluorescence in the range of 520nm. This mode is simple and doesn't require complex instrumentation.

# Protocol materials

X Citric Acid P212121 Step 1

Synt	hesis of Carbon Dots using Citric acid (Solvent Free reaction)	42m
1	X Citric Acid P212121	2m
	☐ 2 g in RB flask and heat on heating mantle and melt the compound	
2	Once you get the yellow molten compound , drop it in the [м] 0.1 Mass Percent 🔗 Sample	15m
	100ml solution, dropwise and stir it on magnetic stirrer.	
3	Then centrifuge the solution at 15000rpm for 🚫 00:25:00 and collect the supernatant and	25m
	characterize it for fluorescence by using UV-Vis spectrophotometer and subsequently by using PL instrument.	
3.1		

### Expected result

In UV-Vis absorption peak will be at 210nm and in PL the excitation peak will be a wide peak in the range of 520 nm